



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Christian Kratzsch et al.

Serial No.:

09/807,061

Filing Date:

07/09/2001

Title:

METHOD FOR SHAPING MATERIALS WITH

PLASMA-INDUCING HIGH-ENERGY RADIATION

Group Art Unit:

2853

Examiner:

Blaise L. Mouttet

Attorney's Docket No.:

STUR-35

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

PETITION FOR AUTOMATIC EXTENSION OF TIME TO RESPOND

Applicants hereby petition for a three (3) month extension of time to respond to the outstanding OFFICE ACTION mailed May 8, 2003, with respect to the above-identified patent application, thereby extending the time for response from August 8, 2003 to November 8, 2003.

A check in the amount of \$475.00 is enclosed to cover the cost of the petition fee. This petition fee has been calculated on the basis of a Small Entity status. 10/31/2003 CMGUYEN 00000081 09807061

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475.00 DP

STUR-35

In the event that any additional fees may be required to be paid in connection with this matter, please charge the same, or credit any overpayment, to Deposit Account No. 16-0221. A duplicate copy of this Petition is enclosed for the convenience of the Office.

Thank you.

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL, POSTAGE PREPAID, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450, ON:

October 28, 2003

(DATE OF DEPOSIT)

SCOTT R. FOSTER

(NAME OF ATTOMNEY)

(SIGNATURE)

October 28, 2003

(DATE OF SIGNATURE)

Respectfully submitted,

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